



11-16-04

EV486245729

2823 #  
JFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application Serial No. ....10/052,313  
Confirmation No .....8400  
Filing Date ..... January 18, 2002  
5 Inventor .....Hodges et al.  
Applicant.....Hewlett-Packard Company  
Group Art Unit .....2823  
Examiner .....Lee, Hsien Ming  
Attorney's Docket No. .... 10004054-1  
10 Title: "Semiconductor Device with Deposited Oxide"

**RESPONSE TO OFFICE ACTION DATED JULY 15, 2004**

To: Commissioner of Patents and Trademarks,  
P.O. Box 1450  
Alexandria, VA 22313-1450

15 From: Dmitry Milikovsky  
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Intellectual Property Administration  
20 P.O. Box 272400  
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This communication is in response to the Office Action dated July 15, 2004, for which a three-month shortened statutory period for response is set for  
25 October 15, 2004. A one-month extension of time is being filed herewith.  
Please amend the above-identified application in accordance the directions set forth below.

**Amendments to the Claims** are reflected in the listing of claims which begin on page 2 of this paper.

30 **Remarks** begin on page 7 of this paper.